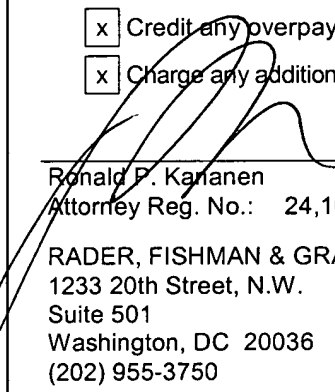


1F2815 \$

AMENDMENT TRANSMITTAL LETTER				Docket No. SON-1718	
Application No. 09/478,812-Conf. #2204		Filing Date January 7, 2000		Examiner E. Lee	
Art Unit 2815					
Applicant(s): Yasukiyasu Sugano et al.					
Invention: PROCESS FOR PRODUCING THIN FILM SEMICONDUCTOR DEVICE AND LASER IRRADIATION APPARATUS					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	14	- 74 =		x	0.00
Independent Claims	14	- 31 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within third month					1,020.00
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					<b>1,020.00</b>
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input type="checkbox"/> No additional fee is required for this amendment.					
<input checked="" type="checkbox"/> Please charge Deposit Account No. <u>18-0013</u> in the amount of \$ <u>1,020.00</u> . A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>18-0013</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
<div> _____ Ronald P. Kananen Attorney Reg. No.: 24,104  RADER, FISHMAN &amp; GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750</div>				Dated: <u>June 13, 2005</u>	
DC197352					



Docket No.: SON-1718  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Yasukiyasu Sugano et al.

Confirmation No. 2204

Application No.: 09/478,812

Art Unit: 2815

Filed: January 7, 2000

Examiner: E. Lee

For: PROCESS FOR PRODUCING THIN FILM  
SEMICONDUCTOR DEVICE AND LASER  
IRRADIATION APPARATUS

**AMENDMENT RESPONSIVE TO ACTION OF DECEMBER 13, 2005**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In full and timely response to the Action of December 13, 2004, please further amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.